

DOCKET NO: 273959US26X PCT

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF

:

TORU KIMURA, ET AL.

: EXAMINER: HYLTON, ROBIN

SERIAL NO: 10/539,571

:

FILED: JUNE 17, 2005

: GROUP ART UNIT: 3781

FOR: VACUUM CONTAINER
APPARATUS USED FOR
MANUFACTURING SEMICONDUCTOR
DEVICES AND LID APPARATUS FOR
SAME.

:

INTERVIEW SUMMARY STATEMENT

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

Pursuant to 37 C.F.R. §1.133 and MPEP 713.04, Applicants respectfully submit the following Interview Summary Statement.

During the interview conducted with the Examiner and Applicants' representative on November 4, 2009, the Examiner provided suggested amendments to Claims 1 and 2 to overcome the rejection under 35 U.S.C. §112, first paragraph, including deletion of the phrase "each of which comprises." Further, support was identified in the specification for the claimed "throughhole...elongated in a vertical direction."

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND,
MAIER & NEUSTADT, L.L.P.



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